

<b>Search Notes</b> 	<b>Application/Control No.</b>  <b>10/657,464</b>	<b>Applicant(s)/Patent under Reexamination</b>  <b>UNEME, MASAKATSU</b>
	<b>Examiner</b>  <b>Hong C. Kim</b>	<b>Art Unit</b>  <b>2185</b>

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner